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PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

10/049170

APPL NUM 10049170	FILING DATE 05/22/2002	CLASS 156	SUBCLASS 89,12	GAU 1734	EXAMINER MAYES
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**CONTINUING DATA VERIFIED:

THIS APPLICATION IS A 371 OF PCT/JP01/04818 06/07/2001

** FOREIGN APPLICATIONS VERIFIED:

JAPAN 2000-170117 06/07/2000

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>	
Foreign priority claimed 35 USC 119 conditions met Verified and Acknowledged Examiners's initials <i>MCM</i>		<input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input checked="" type="checkbox"/> yes <input type="checkbox"/> no	ATTORNEY DOCKET NO MAT-8211US
TITLE : Method for producing ceramic substrate			

U.S. DEPT. OF COMM./PAT. & TM-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims 10	First Claim for 0/0
Assistant Examiner		DRAWING	
Primary Examiner		Claims Drawn 10/10	Figures Drawn 10/10
PREPARED FOR ISSUE		Application Examiner	
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